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ev. 04/03

Docket No. ELM-1 Cont. 10

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Glenn J. Leedy

Application No.:

10/700,429

Confirmation No.: 5639

Filed

November 3, 2003

For

MEMBRANE IC FABRICATION (AS AMENDED)

Group Art Unit :

3729

Examiner

Not yet assigned

New York, New York July 8, 2004

Hon. Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

TRANSMITTAL LETTER FOR INFORMATION DISCLOSURE STATEMENT

Sir:

Transmitted herewith is an Information Disclosure
Statement in the above-identified application. This
Statement is submitted:

- [] within three months of the application filing date;
- [X] more than three months from the application filing date but before the mailing date of the first Office Action on the merits.

In accordance with 37 C.F.R. § 1.97, submission of this Statement requires no fee. However, if for any reason a fee is due, the Director is hereby authorized to charge payment of any fees required in connection with this

Information Disclosure Statement to Deposit Account No. 06-1075. A duplicate copy of this letter is transmitted herewith.

Respectfully submitted,

Philip R. Poh

Registration No. 51,176

Agent for Applicants

FISH & NEAVE

Customer No. 1473

1251 Avenue of the Americas

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I hereby certify that this Correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope Addressed to:

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P.O. Box 1450

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Claire J

Signature of Person Signing



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Glenn J. Leedy

Application No.: 10/700,429 Confirmation No.: 5639

Filed: November 3, 2003

For : MEMBRANE IC FABRICATION (AS AMENDED)

Group Art Unit : 3729

Examiner : Not yet assigned

Hon. Commissioner for Patents

P.O. Box 1450

Alexandrian, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97, applicant wishes to call the attention of the Examiner to the following documents:

U.S. Patents

Fujii et al.	Re. 34,893	04/04/95
Foster	2,915,722	12/01/59
Farrand	3,202,948	08/24/65
Lesk	3,559,282	02/02/71
Burkhardt	3,560,364	02/02/71
Emmasingel	3,602,982	09/07/71
Medicus	3,615,901	10/26/71
Napoli et al.	3,716,429	02/13/73
Krishna et al.	3,777,227	12/14/73
Kuipers	3,868,565	02/25/75
Yerman	3,922,705	11/25/75
Wanlass	3,997,381	12/14/76
Stein	4,070,230	01/24/78

Greenwood et al.	4,131,985	01/02/79
Hauser, Jr., et al.	4,142,004	02/27/79
Hoeberechts	4,251,909	02/24/81
		•
Kubacki	4,262,631	04/21/81
Shioya et al.	4,394,401	07/19/83
Trenkler et al.	4,401,986	08/30/83
Thomas et al.	4,416,054	11/22/83
Takagi et al.	4,539,068	09/03/85
Reid et al.	4,585,991	04/29/86
Yasumoto et al.	4,612,083	09/16/86
Belanger et al.	4,617,160	10/14/86
Shimizu et al.	4,618,397	10/21/86
Schmitz	4,618,763	10/21/86
Christensen	4,663,559	05/05/87
Burns et al.	4,684,436	08/04/87
Hatada	4,693,770	09/15/87
Maeda et al.		10/27/87
	4,702,336	
Seibert et al.	4,702,936	10/27/87
Go	4,706,166	11/10/87
Stevenson	4,721,938	01/26/88
Reid	4,761,681	08/02/88
Holmen et al.	4,784,721	11/15/88
Freeman	4,810,673	03/07/89
Mattox et al.	4,825,277	04/25/89
Tam et al.	4,857,481	08/15/89
Leedy	4,924,589	05/15/90
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Borel et al.	4,940,916	07/10/90
Borel et al.	ReB14,940916	11/26/96
Vranish et al.	4,950,987	08/21/90
Lee et al.	4,952,446	08/18/90
Rokos	4,954,865	09/04/90
		•
Shinomiya	4,957,882	09/18/90
Young et al.	4,965,415	10/23/90
Mauger	4,966,663	10/30/90
Leedy	4,994,735	02/19/91
Keogh et al.	5,008,619	04/16/91
_		04/23/91
Allen et al.	5,010,024	•
Leedy	5,020,219	06/04/91
Leedy	5,034,685	07/23/91
Greenwald et al.	5,070,026	12/03/91
Findler et al.	5,071,510	12/10/91
Machado et al.		03/24/92
	5,098,865	•
Leedy	5,103,557	04/14/92
Mauger	5,110,373	05/05/92
Eichelberger	5,111,278	05/05/92
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Miller	5,130,894	07/14/92
	E 13A 00A	

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Hadwin 5,151,775 09/29/92
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Val	5,637,536	06/10/97
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Bozso et al.	5,760,478	06/02/98
Okonogi	5,773,152	06/30/98
Rolfson	5,786,116	07/28/98
Zavracky et al.	5,793,115	08/11/98
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Leedy	5,834,334	11/10/98
Leedy	5,840,593	11/24/98
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Sweatt et al.	5,870,176	02/09/99
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Hübner	5,902,118	05/11/99
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Cutter et al.	5,998,069	12/07/99
Leedy	6,008,126	12/28/99
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Adamic, Jr.	6,084,284	07/04/00
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Tayanaka	6,194,245 B1	02/27/01
Aleshin et al.	6,197,456 B1	03/06/01
Leedy	6,208,545 B1	03/27/01
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Other Documents

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Alloert, K., et al., "A Comparison Between Silicon Nitride Films Made by PCVD of N_2 -SiH $_4$ /A $_r$ and N_2 -SiH $_4$ /He," Journal of the Electrochemical Society, Vol. 132, No. 7, pp. 1763-1766, (July 1985).

Hendricks, et al., "Polyquinoline Coatings and Films: Improved Organic Dielectrics for IC's and MCM's," Eleventh IEEE/CHMT International Electronics Manufacturing Technology Symposium, "pp. 361-265 (1991).

Knolle, W.R., et al., "Characterization of Oxygen-Doped, Plasma-Deposited Silicon Nitride," Journal of the Electrochemical Society, Vol. 135, No. 5, pp. 1211-1217, (May 1988).

Nguyen, S.V., "Plasma Assisted Chemical Vapor Deposited Thin Films for Microelectronic Applications, J. Vac. Sci. Technol. Vol. B4, No. 5, pp.1159-1167, (Sep/Oct. 1986).

Olmer, et al., "Intermetal Dielectric Deposition by Plasma Enhanced Chemical Vapor Deposition," Fifth IEEE/CHMT International Electronic Manufacturing Technology Symposium - Design-to-Manufacturing Transfer Cycle," pp. 98-99 (1988).

Runyan, W.R., "Deposition of Inorganic Thin Films," Semiconductor Integrated Circuit Processing Technology, p. 142 (1990).

Sze, S.M., "Surface Micromachining," Semiconductor Sensors, pp. 58-63 (1994).

Vossen, John L., "Plasma-Enhanced Chemical Vapor Deposition," Thin Film Processes II, pp. 536-541 (1991).

Wolf, Stanley, "Basic of Thin Films," Silicon Processing for the VLSI Era, pp. 115, 192-193 and 199 (1986).

Copies of the aforementioned documents are listed on the accompanying Form PTO-1449 (submitted in duplicate).

It is respectfully requested that these documents be:

(1) fully considered by the Patent and Trademark Office

during the examination of this application; and (2) printed

on any patent which may issue on this application.

Applicant requests that a copy of Form PTO-1449, as

considered and initialized by the Examiner, be returned with

the next communication.

Consideration of the foregoing in relation to this patent application is respectfully requested.

Respectfully submitted,

Philip R. Poh

Registration No. 51,176

Agent for Applicant

FISH & NEAVE

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Tel.: (212) 596-9000

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Alexandria, VA 2313-1450 on

Claire J Salmid-Van Googlyan

Signature of Person Signing



U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

ATTY. DOCKET NO. ELM-1 Cont. 10	APPLICATION NO. 10/700,429
APPLICANT Glenn J. Leedy	CONFIRMATION NO. 5639
FILING DATE November 3, 2003	GROUP 3729

U.S. PATENT DOCUMENTS

EXAMINE R INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	Re. 34,893	04/04/95	Fujii et al.	257	419	
	2,915,722	12/01/59	Foster	336	115	
	3,202,948	08/24/65	Farrand	336	115	
	3,559,282	02/02/71	Lesk	438	113	
	3,560,364	02/02/71	Burkhardt	324	207.12	
	3,602,982	09/07/71	Emmasingel	29	577	
	3,615,901	10/26/71	Medicus	148	11.5 R	
	3,716,429	02/13/73	Napoli et al.	156	17	
	3,777,227	12/14/73	Krishna et al.	257	578	
	3,868,565	02/25/75	Kuipers	324	207.26	
	3,922,705	11/25/75	Yerman	357	26	
-	3,997,381	12/14/76	Wanlass	156	3	
	4,070,230	01/24/78	Stein	156	657	
-	4,131,985	01/02/79	Greenwood et al.	29	580	
	4,142,004	02/27/79	Hauser, Jr. et al.	438	792	
	4,251,909	02/24/81	Hoeberechts	29	580	
	4,262,631	04/21/81	Kubacki	118	723MP	
	4,394,401	07/19/83	Shioya et al.	427	574	
	4,401,986	08/30/83	Trenkler et al.	340	870.32	
	4,416,054	11/22/83	Thomas et al.	29	572	
	4,539,068	09/03/85	Takagi et al.	156	614	
	4,585,991	04/29/86	Reid et al.	324	158 P	
	4,612,083	09/16/86	Yasumoto et al.	156	633	
	4,617,160	10/14/86	Belanger et al.	264	40.1	
	.4,618,397	10/21/86	Shimizu et al.	156	628	
	4,618,763	10/21/86	Schmitz	250	211R	
	4,663,559	05/05/87	Christensen	313	336	
	4,684,436	08/04/87	Burns et al.	216	65	
	4,693,770	09/15/87	Hatada	156	151	

EXAMINER

	FOF COMMERCE DEMARK OFFICE	ATTY. DOC ELM-1 Con		APPLICATION NO. 10/700,429	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			APPLICAN Glenn J. Le		CONFIRMATION NO. 5639
			FILING DATE		GROUP 3729
4,702,336	10/27/87	Maeda et al.	180	197	
4,702,936	10/27/87	Seibert et al.	427	583	
4,706,166	11/10/87	Go	361	403	
4,721,938	01/26/88	Stevenson	338	4	
4,761,681	08/02/88	Reid	357	68	
4,784,721	11/15/88	Holmen et al.	156	647	
4,810,673	03/07/89	Freeman	438	386	
4,825,277	04/25/89	Mattox et al.	257	639	
4,857,481	08/15/89	Tam et al.	438	619	
4,924,589	05/15/90	Leedy	438	6	
4,940,916	07/10/90	Borel et al.	313	306	
Re B14,940,9	16 11/26/96	Borel et al.	315	306	
4,950,987	08/21/90	Vranish et al.	324	207.23	
4,952,446	08/18/90	Lee et al.	428	220	
. 4,954,865	09/04/90	Rokos	257	378	
4,957,882	09/18/90	Shinomiya	438	65	
4,965,415	10/23/90	Young et al.	200	83 N	
4,966,663	10/30/90	Mauger	205	656	
4,994,735	02/19/91	Leedy	324	158	
5,008,619	04/16/91	Keogh et al.	324	207.17	
5,010,024	04/23/91	Allen et al.	438	659	
5,020,219	06/04/91	Leedy	29	846	
5,034,685	07/23/91	Leedy	324	158 F	
5,070,026	12/03/91	Greenwald et al.	437	3	
5,071,510	12/10/91	Findler et al.	156	647	
5,098,865	03/24/92	Machado et al.	438	788	
5,103,557	04/14/92	Leedy	29	832	
5,110,373	05/05/92	Mauger	148	33.2	
5,111,278	05/05/92	Eichelberger	357	75	
5,116,777	05/26/92	Chan et al.	438	234	
5,130,894	07/14/92	Miller	361	393	
5,132,244	07/21/92	Roy	438	477	

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOC ELM-1 Cont		APPLICATION NO. 10/700,429 CONFIRMATION NO. 5639	
IN	APPLICANT Glenn J. Le					
3	TATEMENT BY APPLI	CANT	FILING DAT November 3		GROUP 3729	
* -						
5,151,	775 09/29/92	Hadwin	357	80		
. 5,156,		Henager, Jr. et al.	428	334		
5,203,		Zimmerman	445	24		
5,225,		Leedy	324	158		
5,236,		Bower et al.	228	193		
5,262,		Bureau et al.	437	183		
5,270,		Bertin et al.	437	209		
5,273,		Sanders	437	209		
5,274,		Tuckerman	257	758		
5,279,		Chebi et al.	427	574		
5,284,		Nakanishi et al.	437	183		
5,323,		Leedy	257	48		
5,324,		Wojnarowski	437	225		
5,354,		Leedy	438	411		
5,363,		MacDonald	315	366		
5,385,		Goossen	156	630		
5,385,		Nelson et al.	514	291		
5,420,	458 05/30/95	Shimoji	257	622		
5,424		Miyake	361	735		
5,426,	072 06/20/95	Finnila	437	208		
5,426,	363 06/20/95	Akagi et al.	324	239		
5,432,	444 07/11/95	Yasohama et al.	324	240		
5,432,		Carson et al.	365	63		
5,434		Hauck et al.	324	67		
5,451,	489 09/19/95	Leedy	430	313		
5,453,		Leedy	437	203		
5,457		Gurtler et al.	29	895		
5,476,		Naruse	437	132		
5,489		Gates	437	208		
5,502		Bertin et al.	365	51		
5,512			430	30		
5,527			430	5		

FORM PTO-1449		IT OF COMMERCE ADEMARK OFFICE			APPLICATION NO. 10/700,429
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			APPLICAN ⁻ Glenn J. Le		CONFIRMATION NO. 5639
			FILING DAT November 3		GROUP 3729
5,529,	829 06/25/96	Koskenmaki et al.	428	167	
. 5,534,		Frye et al.	437	209	
5,555,		Toshiaki et al.	365	200	
5,563,		Ramm et al.	437	51	
5,571,		Leedy	437	51	
5,580,		Leedy	430	5	
5,581,		Ludwig et al.	365	63	
5,582,		Pierrat	430	5	
5,583,		Hornbeck	359	291	
5,592,		Leedy	257	347	
5,592,		Leedy	257	619	
5,595,		Heijboer	439	20	
5,606,		Noda	257	226	
5,627,		Tennant et al.	438	113	
5,629,	i	Leedy	430	313	
5,633,		Leedy	435	228	
. 5,637,		Val	438	686	
5,654,		Leedy	430	315	
5,654,		Leedy	438	25	
5,656,	552 08/12/97	Hudak et al.	438	15	
5,675,		Chen et al.	257	774	
5,694,	588 12/02/97	Ohara et al.	395	566	
5,725,		Leedy	430	315	
5,750,	211 05/12/98	Weise et al.	427	579	
5,760,	478 06/02/98	Bozso et al.	257	777	
5,773,		Okonogi	428	446	
5,786,		Rolfson	430	5	
5,793,		Zavracky et al.	257	777	
5,831,		Ray	257	48	
5,834,		Leedy	438	107	
5,840,		Leedy	438	6	
5,856,		Ito et al.	257	370	

FORM PTO-1		ENT OF COMMERCE TRADEMARK OFFICE							TION NO. 9	
	INFORMATIO	ON DISC	LOSURE			APPLICANT		CONFIRM 5639	CONFIRMATION NO.	
	STATEMENT	BY AP	PLICAI				Glenn J. Leedy FILING DATE November 3, 2003		GROUP 3729	-
		-	-							· · · · · · · · · · · · · · · · · · ·
	5,868,949	02/09/	99 5	Sotokaw	a et al.	21	16	18		
	5,869,354	02/09/		.eedy		43		110		,
	5,870,176 02/09/			Sweatt e	t al.	35		53		
	5,880,010	03/09/		Davidsor		43		455		
	5,882,532 03/16			ield et a		21		2		
	5,902,118	05/11/	<u> </u>	Hübner		43		106		
	5,915,167 06/22/ 5,946,559 08/31/ 5,985,693 11/16/ 5,998,069 12/07/ 6,008,126 12/28/ 6,020,257 02/01/ 6,045,625 04/04/			.eedy		43		108		
				eedy		43		157		
				eedy		43		107		
			07/99 Cutter et al. 28/99 Leedy 01/00 Leedy		al.	43	30	5		
					43	438 667 438 626 148 33.3				
					43					
					14					
	6,084,284	07/04/	01/00 Gardner et al.		25	257 506				
_	6,097,096	08/01/			et al.	25	257 777			
•	6,133,640	10/17/					257 7			
	6,194,245 B1	02/27/	01 1			43	38	57		
•	6,197,456 B1	03/06/			Aleshin et al.		430 5			
	6,208,545 B1	03/27/01		Leedy		36	35	51		
	6,236,602 B1	05/22/	01 F	Patti Lin Leedy		36	35	201		
	6,261,728 B1	07/17/	01 L			43	30	30		
	6,288,561 B1	09/11/	01 L			32	24	760		
	6,294,909 B1	09/25/	01 L	eedy		32	24	207.17		
			FOR	EIGN P	ATENT DOCU	MENTS	3			<u>.</u>
EXAMINER INITIAL	DOCUMENT NU	IMBER	DA	ATE	COUNTRY	CL	.ASS	SUBCLA	SS TRA	NSLATION NO
	WO 98/19337		05/19	998	PCT	H01I	L	21/44		
	GB 2,215,168		09/19		UK	G09		1/00		
	EP 0 189 976		08/19		EPO	H01I		31/18		
	EP 0 731 525		09/19		EPO	H011		5/00		
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